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<b>Notice of Allowability</b>	<b>Application No.</b>	<b>Applicant(s)</b>
	10/661,547	JOSHI, POORAN C. Art Unit
	Examiner Toniae M. Thomas	2822

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address--

All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.

1.  This communication is responsive to the amendment filed on 09 February 2005.
2.  The allowed claim(s) is/are 7 and 17-23.
3.  The drawings filed on 19 January 2005 are accepted by the Examiner.
4.  Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
  - a)  All
  - b)  Some\*
  - c)  None
 of the:
  1.  Certified copies of the priority documents have been received.
  2.  Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
  3.  Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).

\* Certified copies not received: \_\_\_\_\_.

Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.  
THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.

5.  A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.
6.  CORRECTED DRAWINGS ( as "replacement sheets") must be submitted.
  - (a)  including changes required by the Notice of Draftsperson's Patent Drawing Review ( PTO-948) attached
    - 1)  hereto or 2)  to Paper No./Mail Date \_\_\_\_\_.
  - (b)  including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date \_\_\_\_\_.
7.  DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.

#### Attachment(s)

1.  Notice of References Cited (PTO-892)
2.  Notice of Draftsperson's Patent Drawing Review (PTO-948)
3.  Information Disclosure Statements (PTO-1449 or PTO/SB/08),  
Paper No./Mail Date \_\_\_\_\_
4.  Examiner's Comment Regarding Requirement for Deposit  
of Biological Material
5.  Notice of Informal Patent Application (PTO-152)
6.  Interview Summary (PTO-413),  
Paper No./Mail Date \_\_\_\_\_
7.  Examiner's Amendment/Comment
8.  Examiner's Statement of Reasons for Allowance
9.  Other \_\_\_\_\_



Mary Wilczewski  
Primary Examiner

***Reasons for Allowance***

The following is an examiner's statement of reasons for allowance: the prior art of record fails to anticipate, teach or suggest a method for fabricating composite thin films substantially as claimed. As stated in the previous Office action mailed on 21 September 2001, Tomita (US 5,468,514) discloses a method for fabricating composite thin films (see fig. 1 and col. 2, line 64 - col. 3, line 3). As discussed in the previous action, Tomita discloses the steps of: after depositing a chemical precursor solution onto a suitable substrate and forming a wet thin film of Ta<sub>2</sub>O<sub>5</sub>, baking the Ta<sub>2</sub>O<sub>5</sub> thin film and removing organics present; forming a continuous Ta<sub>2</sub>O<sub>5</sub> thin film on the substrate, and baking the continuous Ta<sub>2</sub>O<sub>5</sub> thin film. However, Tomita does not anticipate, teach or suggest the following limitation of: drying the thin film subsequent to depositing a chemical precursor solution onto the substrate and forming a wet thin film of Ta<sub>2</sub>O<sub>5</sub>, and prior to baking the Ta<sub>2</sub>O<sub>5</sub> thin film and removing organics present. There is no teaching or suggestion within the prior art of record to modify Tomita by drying the thin film subsequent to depositing a chemical precursor solution onto the substrate and forming a wet thin film of Ta<sub>2</sub>O<sub>5</sub>, and prior to baking the Ta<sub>2</sub>O<sub>5</sub> thin film and removing organics present.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Toniae M. Thomas whose telephone number is (571) 272-1846. The examiner can normally be reached on Monday-Thursday from 8:30 a.m. to 5:30 p.m..

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amir Zarabian can be reached on (571) 272-1852. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

TMT  
19 February 2005



Mary Wilczewski  
Primary Examiner